



# EVG NIL Technology Day

Israel  
March 14, 2023

## Schedule

March 14, 2023  
10:00 - 16:15 hrs  
EVG Technology Day

## Location

Daniel Herzliya Hotel,  
60 Ramat Yam Street,  
Kefar Sava, 48905, Israel

## Register

For more information  
and to register for free:

[www.EVGroup.com/events](http://www.EVGroup.com/events)

## Latest Trends in AR/VR, Silicon Photonics, Automotive and Meta Lenses

### Agenda\*

09:30	Registration
10:00	<b>Welcome and Introduction</b> Eli Dassa, NoamTech and Dr. Josef Meiler, EV Group (EVG)
10:15	<b>NIL Market Update</b> Andrea Kneidinger, Business Development Manager, EV Group (EVG)
10:45	<b>Metaoptics produced but Nanoimprint Lithography and dry etching</b> Brian Bilenberg, Founder and Executive VP, NILT
11:15	<b>Industrial mastering of NIL Masters for AR/VR Applications and Metalenses</b> Dr. Martin Sczyrba, TOPPAN Photomasks/ AMTC Dresden
11:45	<b>Advances in Inkron resin technology for the NIL process</b> Juha Pietarinen, INKRON
12:15	Lunch
13:15	<b>NIL Process Capabilities</b> Patrick Schuster, Process Technology Engineer, EV Group (EVG)
13:45	<b>NIL Equipment Portfolio</b> Anna Dudus, Product Manager, EV Group (EVG)
14:15	<b>Advanced Dry Etching of 2D and 3D nano-structures for master mould fabrication and other applications</b> João Ferreira, Oxford Instruments
14:45	Coffee Break
15:05	<b>NIL Latest Developments</b> Christine Thanner, Technology Development, EV Group (EVG)
15:35	<b>NanoImprint Lithography for scalable silicon photonics packaging</b> Hesham Taha, CEO and Co-Founder, Teramount
16:05	Summary and Wrap-Up

\* Preliminary Agenda



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